



## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Reissue patent application of : Mail Stop Amendment

Oh-Sung SONG et al. : Group Art Unit 2823

Serial No. 10/608,221 : Examiner Fourson III

Filed June 30, 2003

METHOD FOR FABRICATING MOS SEMICONDUCTOR DEVICE HAVING SALICIDE REGION AND LDD REGION

## **AMENDMENT**

U.S. Patent and Trademark Office Customer Service Window, **Mail Stop Amendment** Randolph Building 401 Dulany Street Alexandria VA 22314

Sir:

In response to the Office Action of September 19, 2005, please amend the aboveidentified application as follows:

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks/Arguments begin on page 4 of this paper.